

Video Measuring System





Nikon

INEXIV VMA Series

Nikon offers the ultimate usability for a wide variety of measuring applications with the wide FOV, long XYZ stroke iNEXIV VMA series.

– Automatically measures various components, such as plastic injection molds and electronic parts, with high accuracy and repeatability

- Allows measurements of tall and uneven objects with the long working distance of 73.5 mm Three models in the iNEXIV VMA series are available, each with a different XY-stroke.

Wide field of view and sharp, clear images

A wide FOV of up to 13 mm x 10 mm (at 0.35x) allows easy search and alignment of measuring targets. The 10x zoom with five specific steps provides accurate measurement as well as high-resolution images. An excellent Apochromat objective lens with high NA (0.11) and low distortion has been specially designed for the iNEXIV series, providing crisp, clear images.

| Optical magnificati | on | 0.35× | 0.6× | 1× | 1.8× | 3.5× |
|--|-------------------------------|---------------|-------------|-------------|-------------|---------------|
| FOV size on stage | Horizontal × Vertical (mm) | 13.3× 10.0 | 7.8× 5.8 | 4.7× 3.5 | 2.6× 1.9 | 1.33× 1.00 |
| 1/3" CCD size | Horizontal × Vertical (mm) | 4.8×3.6 | | | | |
| Video magnification | | 36 | | | | |
| Total magnification on Video Window (640 × 480 pixels)* | | 12.6 | 21.6 | 36 | 64.8 | 126 |
| Size of 1 pixel (micrometer) | | 21.8 | 12.6 | 7.36 | 4.25 | 2.15 |

* Total magnification is that of video window with 640 × 480 pixels on 24 inch WUXGA monitor (1920 × 1200 pixels) recommended for VMZ-R series.



Robust 73.5 mm working distance

A long working distance minimizes the possibility of contact between the objective lens and valuable samples. Ideal for measuring large step heights and deep holes.



Working distance 73.5 mm

Large XY stroke and long Z stroke

Three models with different XY strokes are available: 250 x 200 mm. 450 x 400 mm and 650 x 550 mm An extended 200 mm Z-axis stroke is perfect for tall samples.

Three models with different XY strokes to suit various sample sizes

 $250 \text{ mm}(X) \times 200 \text{ mm}(Y) \times 200 \text{ mm}(Z) - \text{Standard stroke}$

INEXIV VMA-2520

A space-saving, low-cost model suited to measure small samples, such as electronic and die cast parts.

| Stroke | 250 (X) x 200 (Y) x 200 (Z) mm |
|-----------------------|----------------------------------|
| Measuring head travel | Z direction (single column type) |
| Stage travel | X-Y direction |

$450 \text{ mm}(X) \times 400 \text{ mm}(Y) \times 200 \text{ mm}(Z) - Middle stroke$

iNEXIV VMA-4540

Suitable for mid-size samples, such as molded and pressed parts.

| Stroke | 450 (X) x 400 (Y) x 200 (Z) mm |
|-----------------------|--------------------------------|
| Measuring head travel | X-Y direction (bridge type) |
| Stage travel | Y direction |

650 mm(X) × 550 mm(Y) × 200 mm(Z) – Large stroke

iNEXIV VMA-6555

Suitable for large sample and simultaneous measurement of multiple parts.

| Stroke | 650 (X) x 550 (Y) x 200 (Z) mm |
|-----------------------|--------------------------------|
| Measuring head travel | X-Y direction (bridge type) |
| Stage travel | Y direction |





Fast and accurate vision AF (Auto Focus)

The high-speed vision AF offers high-repeatability and high-precision for height and depth measurement. Noncontact measurement using the vision AF does not damage or deform parts.









Even the bottom of a small hole can be focused.

Top surface of implant

Mid-depth of implant Mid-depth of implant

Versatile illuminations

The iNEXIV VMA series is equipped with episcopic (top), diascopic (bottom) and 8-segment ring (with 18-degree obligue angle) LED illuminators. Combining these illuminators with superior optics provides accurate detection of low contrast edges.





Ring light from left side





Any 8-seament light can be selected for effective edge detection.

Top light

Intelligent search



Digital chart comparator

Even when a sample is misaligned, the system automatically searches the target location based on the target image recorded in a teaching file. This enables accurate, automatic measurement by eliminating possible detection errors.





Deviation of contours can be checked by overlaying charts generated digitally from

2D CAD data onto video images. Digital charts always accompany video images.



Misaligned target can be automatically detected using intelligent search



Software

User-friendly standard software NEXIV AutoMeasure

NEXIV AutoMeasure, dimensional measurement software for the ever-evolving NEXIV series. Support functions to create measurement programs have been further enhanced, making fast, highly accurate dimensional measurements easier than ever before.

Graphical user interface to efficiently create programs with intuitive operation and easy-to-understand guide

Measurement programs can be created by selecting the icon for edge detection and that which should be measured.



Edge detection and AF icon

Automated edge setting function

Edge detection conditions are automatically set by simply selecting the target edge from the waveform profile. Even if multiple edge candidates are detected, the operator can specify the correct edge, improving the simplicity and efficiency of operation. Select by a radio button



Lighting optimization function

Automatically optimizes the type of lighting, direction of ring illumination, and light intensity according to features of object measured. Makes it possible to reduce the amount of time and effort spent creating measurement programs.

*Optimizations may not be possible depending on shape of object measured.



edge of height variations in the

(Optimization with epi-illumination)

patterned area of a PCB.

Result of lighting optimization, detecting edge of condenser component mounted on a PCB. (Optimization of light source direction and intensity with ring illumination)





XY coordinate after searching the target





| O Hpe- | / lie. |
|-----------------------|------------|
| D Rate- | V tecarge. |
|) Sphere. | Cone. |
| ArcDat. from center). | |

Various measurement icons



Teaching navigation

Simply follow the on-screen instructions and the required measurement settings are entered automatically. Even firsttime users can create basic measurement programs.



Evaluation of shapes --

Errors can be visualized by overlaying nominal and measured shapes. Can be used for both geometrical shapes and free-form shapes.

Offline teaching

Computer-aided design (CAD) data can be used to create measurement programs for offline teaching before any sample is obtained. Working on a separate computer* to the NEXIV main unit frees it up so it can be used to full capacity. *Dongle key required. Please contact Nikon for any offline teaching requests.

EDF/Stitching Express (option) ------

Image analysis and archiving program for creating an all-in-focus EDF (Extended Depth of Focus) image from multiple images at different height. This also generates a stitched image on the same XY plane.

Optional Hardware

Dimensional Diagram

Touch probe for measurement of imperceptible parts

The iNEXIV VMA series can accommodate optional Renishaw® TP20 or TP200 touch probes. Touch probes provide measurements where vision AF cannot be used, such as the inner diameter of an oil seal or the clearance angle of an indexable insert. Measurement can be easily switched between video and touch probe, and both can be controlled by measurement program.





Inner diameter of oil seal





Clearance angle of insert

Extended 1.5x high-magnification



Each model can be modified before shipment to extend the magnification to 1.5x, powerful enough for precise measurement of minute electronic parts.

*Video measuring images are slightly darker with the 1.5x high-magnification option, even with the same light

Smartphone charger



intensity setting (0 - 100).





8.9 mm (W) x 6.7 mm (H)

1.5x 5.2 mm (W) x 3.9 mm (H) 3.1 mm (W) x 2.3 mm (H)



2.7x 1.9 mm (W) x 1.3 mm (H)



5.2x 0.89 mm (W) x 0.67 mm (H)

Laser AF

With a working distance of 63 mm, the optional Laser AF enables height measurement of flat surfaces with high repeatability, while keeping a wide FOV at low magnification.











Specifications

| Model | VMA-2520 | VMA-4540 | VMA-6555 | |
|--|---|---|---------------------------------|--|
| XYZ Strokes | 250×200×200 mm | 450×400×200 mm | 650×550×200 mm | |
| Measurement range with TP | 200×200×166 mm (TP20) | 400×400×166 mm (TP20) | 600×550×166 mm (TP20) | |
| (Touch Probe) | 200×200×170 mm (TP200) | 400×400×170 mm (TP200) | 600×550×170 mm (TP200) | |
| | 250×200×200 mm (with Vision AF) | 450×400×200 mm (with Vision AF) | 650×550×200 mm (with Vision AF) | |
| Measurement range | 175×200×166 mm (TP20) | 325×400×166 mm (TP20) | 525×550×166 mm (TP20) | |
| with TP & MCR20*1 | 175×200×170 mm (TP200) | 325×400×170 mm (TP200) | 525×550×170 mm (TP200) | |
| | 225×200×200 mm (with Vision AF) | 375×400×200 mm (with Vision AF) | 575×550×200 mm (with Vision AF) | |
| Minimum readout | 0.1 µm | | | |
| Maximum sample weight | 15 kg | 40 kg | 50 kg | |
| Maximum sample weight (accuracy guaranteed) | 5 kg | 20 kg | 30 kg | |
| Maximum permissible error*2 | Eux, MPE Euy, MPE: 2+8 <i>L</i> /1000 μm | Еих,мре Еиу,мре: 2+6 <i>L</i> /1000 µm | | |
| (L = Length in mm) | EUXY,MPE: 3+8 <i>L</i> /1000 μm EUZ,MPE* ³ : 3+ <i>L</i> /50 μm | Euxy,mpe: 3+6 <i>L</i> /1000 μm Euz.mpe*3: 3+ <i>L</i> /100 μm | | |
| Camera | | | | |
| | 1/3" Black and White CCD, 1/3" Color CCD | | | |
| Working distance | 73.5 mm (63 mm with Laser AF) | | | |
| Magnification | Optical: 0.35 to 3.5x (0.52x to 5.2x high magnification is available as an option) On screen: 12.6 to 126x with 24-inch WUXGA (1920×1200 pixels) monitor | | | |
| FOV size on stage | 13.3×10 mm to 1.33×1 mm (8.9×6.7 mm to 0.89×0.67 mm with high-magnification option) | | | |
| Autofocus | Vision AF, Laser AF (option) | | | |
| Illumination | Contour illumination and Surface illumination: White LED diascopic illumination | | | |
| | Oblique illumination: 8-segment white LED ring illumination | | | |
| Video resolution | 640×480 pixels | | | |
| Touch probe (optional) | Renishaw® TP200/TP20 | | | |
| Power source | 100 V-240 V, 50/60 Hz | | | |
| Power consumption | 5 A (100 V) - 2.5 A (240 V) | | | |

*1: The iNEXIV-dedicated MCR20 can be used for both TP20 and TP200. *2: Nikon's in-house test at 20°C ±0.5k *3: With TP or Laser AF

| Nikon Corporation Industrial Solutions Business Unit is certified as an ISO/IEC 17025 accredited calibration laboratory for video measuring systems by the IAJapan (International Accreditation Japan) as Accreditation No.JCSS0241. ISO/IEC 17025: International standard, which specifies the general requirements to ensure that a laboratory is competent to carry out specific tests and/or calibrations | Date of initial accreditation: | July 1, 2009 | |
|--|--|--|--|
| | Scope of accreditation: | Coordinate measuring instruments | |
| | Accredited section: | Industrial Solutions Business Unit | |
| | Calibration site: | Customer's laboratory (field service) | |
| | Calibration and Measurement Capability (CMC), (K=2, Level of Confidence Approximately 95%) [<i>L</i> =measurement length (mm)] | L ≤ 420 mm: 0.32 μm 420 ≤ L ≤ 1000 mm : (0.29 + 0.64 × L/1000) μm | |

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TO ENSURE CORRECT USAGE, READ THE CORRESPONDING MANUALS CAREFULLY BEFORE USING THE EQUIPMENT.



🔥 WARNING

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